

<b>Notice of References Cited</b>	Application/Control No. 10/604,907	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Monica Lewis	Art Unit 2822	Page 1 of 1

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	B	US-6,271,094	08-2001	Boyd et al.	438/287
	C	US-2004/0007724	01-2004	Murthy et al.	257/288
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	M	US-			

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**NON-PATENT DOCUMENTS**

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	U	Peter Van Zant, Microchip Fabrication, 2000, McGraw-Hill, Page 37.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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